

<b>Notice of References Cited</b>	Application/Control No. 09/832,933	Applicant(s)/Patent Under Reexamination WU ET AL.	
	Examiner Thomas H. Stevens	Art Unit 2123	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hu, C., "Invited Paper Gate Oxide Scaling Limits and Projection" pg. IEEE 1996, pg.13.1.1-13.1.4
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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